L Number	Hits	Search Text	DB	Time stamp
-	8	((insulating or dielectric or insulation or	USPAT;	2004/08/04
		oxide) adj substrate) and (transparent adj	US-PGPUB;	16:03
		electrode).clm. and (black adj matrix).clm.	EPO; JPO;	
		and protrusion	DERWENT;	
i		and protiusion	IBM_TDB	
	19	((insulating or dielectric or insulation or	USPAT;	2004/08/04
-	13	··· =	•	l —
		oxide) adj substrate) and (transparent adj	US-PGPUB;	16:03
		electrode) and (black adj matrix).clm. and	EPO; JPO;	
		protrusion	DERWENT;	
	_	<u> </u>	IBM_TDB	
•	3	((insulating or dielectric or insulation or	USPAT;	2004/08/04
		oxide) adj substrate) same (transparent adj	US-PGPUB;	16:05
		electrode) same (black adj matrix) same	EPO; JPO;	
		protrusion	DERWENT;	
			IBM_TDB	
-	3	(((insulating or dielectric or insulation or	USPAT;	2004/08/04
		oxide) adj substrate) and (transparent adj	US-PGPUB;	16:05
		electrode) and (black adj matrix) and	EPO; JPO;	
		protrusion).ti,ab,clm.	DERWENT;	
			IBM_TDB	
_	43	((insulating or dielectric or insulation or	USPAT;	2004/08/04
		oxide) adj substrate) and (transparent adj	US-PGPUB;	16:09
		electrode) and (black adj matrix) and	EPO; JPO;	10.00
		protrusion	DERWENT;	
		protrasion	IBM_TDB	
	32	((insulating or dielectric or insulation or	USPAT;	2004/08/04
	JŁ	···	· ·	16:10
		oxide) adj substrate) and (transparent adj	US-PGPUB;	16:10
		electrode) and (black adj matrix) and	EPO; JPO;	
		protrusion and ((transparent near electrode)	DERWENT;	
		near10 substrate)	IBM_TDB	
-	32	((insulating or dielectric or insulation or	USPAT;	2004/08/04
		oxide) adj substrate) and (transparent adj	US-PGPUB;	16:10
		electrode) and (black adj matrix) and	EPO; JPO;	
		protrusion and ((transparent adj electrode)	DERWENT;	
		near10 substrate)	IBM_TDB	
-	17059	((transparent adj electrode) near5	USPAT;	2004/08/04
		substrate)	US-PGPUB;	16:10
			EPO; JPO;	
			DERWENT;	
			IBM_TDB	
-	165	((transparent adj electrode) near5	USPAT;	2004/08/04
		substrate) and ((black near matrix) near5	US-PGPUB;	16:10
		(transparent adj electrode))	EPO; JPO;	
			DERWENT;	
			IBM_TDB	
.	18	((transparent adj electrode) near5	USPAT;	2004/08/04
		substrate) and ((black near matrix) near5	US-PGPUB;	16:16
		(transparent adj electrode)) and protrusion	EPO; JPO;	<del></del> -
		, promote promo	DERWENT;	
			IBM_TDB	

	10	((transparent adj electrode) near5	USPAT;	2004/08/04
		substrate).clm. and ((black near matrix)	US-PGPUB;	16:16
		near5 (transparent adj electrode)) and	EPO; JPO;	
		protrusion	DERWENT;	
			IBM_TDB	
	3	((transparent adj electrode) near5	USPAT;	2004/08/04
		substrate).clm. and ((black near matrix)	US-PGPUB;	16:20
		near5 (transparent adj electrode)).clm. and	EPO; JPO;	
		protrusion	DERWENT;	
			IBM_TDB	
	14	((transparent adj electrode) near5	USPAT;	2004/08/04
		substrate).clm. and ((black near matrix)	US-PGPUB;	16:25
		near5 (transparent adj electrode)).clm.	EPO; JPO;	
			DERWENT;	
			IBM_TDB	
	1	(((transparent adj electrode) near5	USPAT;	2004/08/04
		substrate).clm. and ((black near matrix)	US-PGPUB;	16:25
		near5 (transparent adj electrode)).clm.) and	EPO; JPO;	:
		chrome	DERWENT;	
			IBM_TDB	
	0	(((transparent adj electrode) near5	USPAT;	2004/08/04
		substrate).clm. and ((black near matrix)	US-PGPUB;	16:25
		near5 (transparent adj electrode)).clm.) and	EPO; JPO;	
		phososensitive	DERWENT;	
			IBM_TDB	
	5	(((transparent adj electrode) near5	USPAT;	2004/08/05
		substrate).clm. and ((black near matrix)	US-PGPUB;	13:00
		near5 (transparent adj electrode)).clm.) and	EPO; JPO;	
		photosensitive	DERWENT;	
		•	IBM_TDB	
	1	(((transparent adj electrode) near5	USPAT;	2004/08/04
	-	substrate).clm. and ((black near matrix)	US-PGPUB;	16:27
		near5 (transparent adj electrode)).clm.) and	EPO; JPO;	
		photosensitive and (photolithography or	DERWENT;	
		lithography)	IBM_TDB	